



17-2823  
PATENT

Customer No. 23,494  
Attorney Docket No. TI-31133  
Application No.: 10/001,483

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Antonio ROTONDARO

Application No.: 10/001,483

Filed: November 1, 2001

For: METHOD TO IMPROVE THE  
UNIFORMITY AND REDUCE THE  
SURFACE ROUGHNESS OF THE  
SILICON DIELECTRIC  
INTERFACE

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)

) Group Art Unit: 2823

)

) Examiner: Michelle Estrada

)

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Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicant hereby petitions for a one month extension of time to reply to the Office Action of January 16, 2004 (May 16, 2004, being a Sunday).

Please grant any extensions of time required to enter this response and charge this and any additional required fees to the Texas Instruments Deposit Account 20-0668.

Respectfully submitted,

Dated: May 17, 2004

By: Timothy A. Hack for

Jonathan A. Hack

Reg. No. 47,623

Reg. # 42,672

05/18/2004 SDENB0B1 00000088 200668 10001483  
01 FC:1251 110.00 DA